



SATHYABAMA
INSTITUTE OF SCIENCE AND TECHNOLOGY
 (Deemed to be University)
 Centre for Nanoscience and Nanotechnology
 Chennai-600119, Tamilnadu, India



Training Program on Thin film Synthesis and Characterization Techniques
(July – December 2019)

S.No	Deposition and characterization Techniques	Registration Fee (Rs.)	Duration	Date
1	DAY- I	3000/-	Two days	19.07.2019 - 20.07.2019
	a. Specimen Preparation; cutting, polishing, pelletizing and Sintering b. Thermal Evaporation c. E-beam Evaporation d. Pulsed Laser Deposition			
2	DAY- II	3000/-	Two days	30.08.2019 - 31.08.2019
	e. Atomic Force Microscopy(AFM) f. Stylus profilometer g. Scanning Electron Microscopy (SEM) h. Impedance Analyzer			
3	DAY- I	3000/-	Two days	27.09.2019 - 28.09.2019
	a. Specimen Preparation; cutting, polishing, pelletizing and Sintering b. Thermal Evaporation c. E-beam Evaporation d. Pulsed Laser Deposition			
	DAY- II			
	e. Atomic Force Microscopy(AFM) f. Stylus profilometer g. Scanning Electron Microscopy (SEM) h. Hall Effect Measurement			

4	<p style="text-align: center;">DAY- I</p> <p>a. Specimen Preparation; cutting, polishing, pelletizing and Sintering b. DC Magnetron Sputtering c. RF Magnetron Sputtering d. Pulsed Laser Deposition</p>	3000/-	Two days	15.11.2019 - 16.11.2019
	<p style="text-align: center;">DAY- II</p> <p>e. Atomic Force Microscopy(AFM) f. Stylus profilometer g. Scanning Electron Microscopy (SEM) h. UV-Spectrophotometer</p>			
5	<p style="text-align: center;">DAY- I</p> <p>a. Specimen Preparation; cutting, polishing, pelletizing and Sintering b. Thermal Evaporation c. E-beam Evaporation d. Pulsed Laser Deposition</p>	3000/-	Two days	13.12.2019 - 14.12.2019
	<p style="text-align: center;">DAY- II</p> <p>e. Atomic Force Microscopy(AFM) f. Stylus profilometer g. Scanning Electron Microscopy (SEM) h. Hall Effect Measurement</p>			

Who can attend?

Faculties & Scientists from Universities, R&D Organizations, Industries, Research Scholars and UG/PG Students interested in the area of the thin film and Characterization Techniques can participate.

Registration:

- Filled application form for participation in the **Training Program on Synthesis and Characterization techniques - 2019** should be sent in the attached format with Registration fee by DD drawn in favor of “**Sathyabama Institute of Science and Technology**”, payable at **Chennai**.
- The Registration fee includes kit and food during the Training Program.
- Certificate will be issued to all the participants.
- Select your **convenient dates** from the above schedule & mail to us.
- **Bulk participation** from same institute will be preferred to arrange a separate training.

Contact us:

Dr.T.Sasipraba, Organizing Secretary,
Pro Vice-Chancellor,

Dr.Vinita Vishwakarma, Convener,
Prof. & Scientist-F

Centre for Nanoscience and Nanotechnology,
Sathyabama Institute of Science and Technology, Jeppiaar Nagar,
Rajiv Gandhi Road, Chennai-600119

Phone: 044-2450 3814/ 3065, Fax: 044-24503814

Email: training@centrefornanotechnology.com, Website: www.centrefornanotechnology.com

BUS Routes

102- from Parris/Adyar/Central/Thiruvanniyur

19B- from Saidapet

570- from Koyembdu

T 151- Tambaram Railway Station



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Training Program - 2019
on
Thin Film Synthesis and Characterisation Techniques

REGISTRATION PROFORMA

Training Dates:

Nature of Participant : Industries/Faculties & Scientists/Research Scholars*/UG-PG Students*/Others

Name :

Designation :

Institute/Company :

Address :

City : PIN/ZIP code :

Country :

Phone (with area code) : Mobile :

E-mail :

Demand Draft Details :

DD No. :

Date :

Amount :

Name of the Bank & Place :

Shared Accommodation Required: Yes/ No

*Enclose ID-card / Certificate from institute

Place:

Date:

Signature